

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: )  
MAEKAWA et al. )  
Serial No.: 10/827,457 )  
Filed: April 19, 2004 )  
For: Method For Forming Pattern And )  
Drop Discharge Apparatus )  
Examiner: Marianne L. Padgett )  
Art Unit: 1762 )  
Confirm No.: 2984 )

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Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT C (AFTER FINAL)**

Applicants have the following response to the Final Rejection of July 6, 2007.

Please amend the above-identified application as follows: